

The SENSEI[†] project

LDRD-2016-004

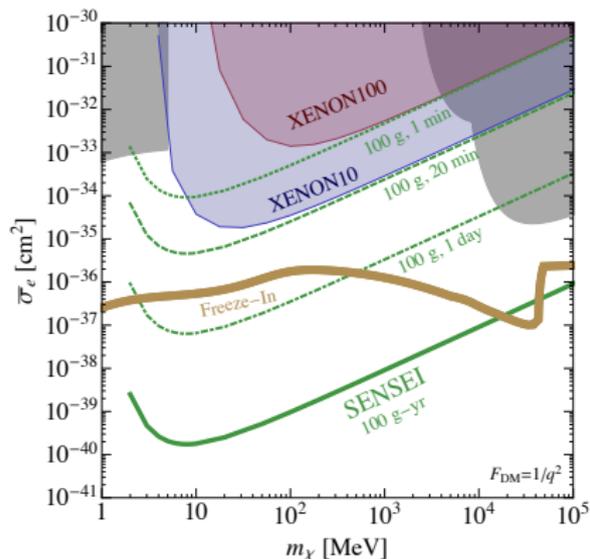
Javier Tiffenberg
Fermi National Laboratory

July 31, 2017

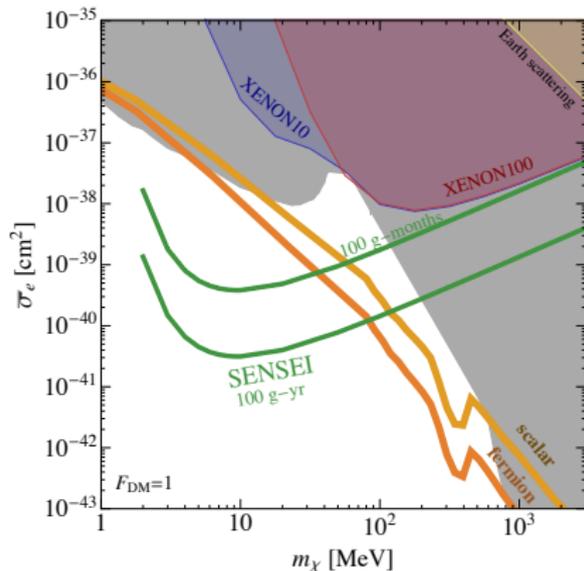
† Sub-Electron-Noise SkipperCCD Experimental Instrument

Motivation for SENSEI: a detector that can do this NOW

Light Dark Photon



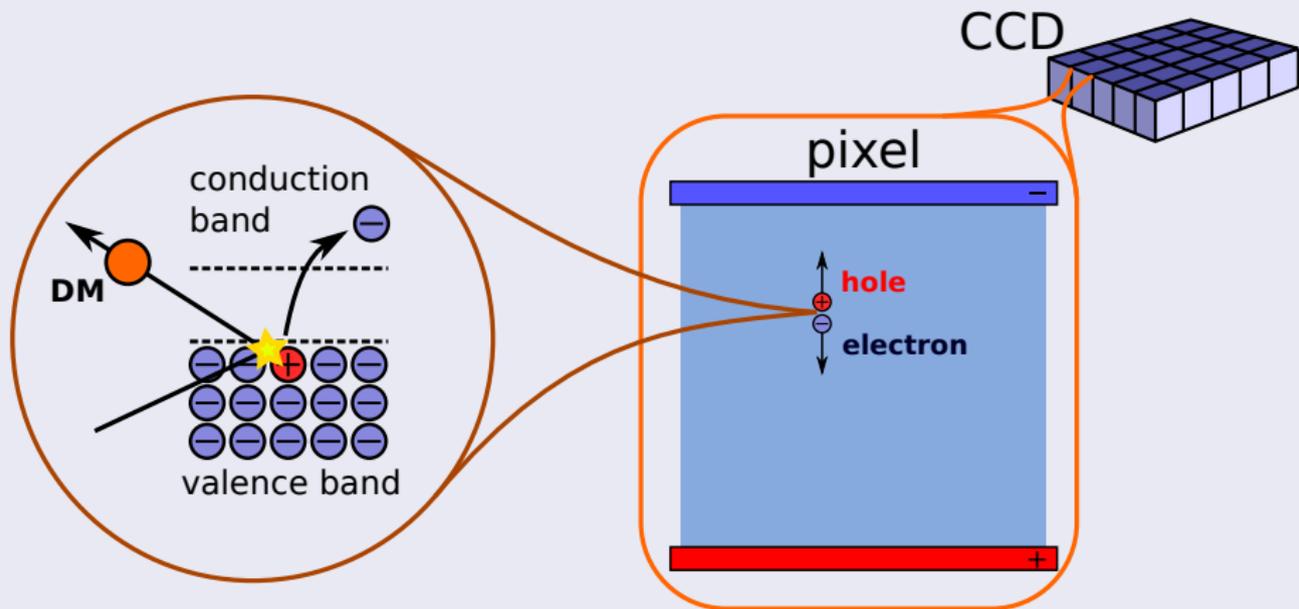
Heavy Dark Photon



Plots from: Rouven Essig, Tomer Volansky & Tien-Tien Yu.

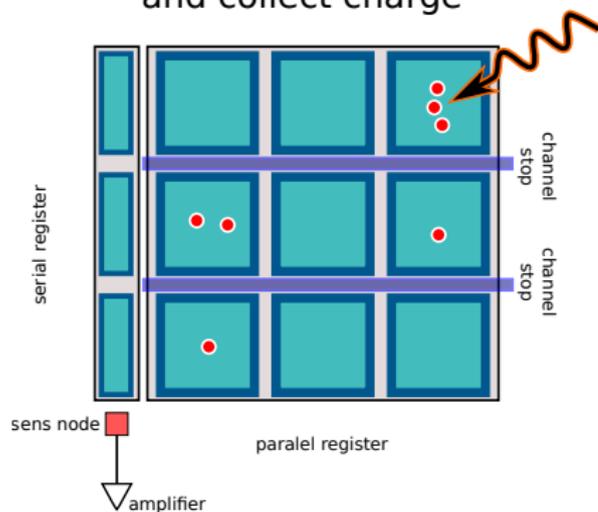
How?

use CCDs as target to record the ionization produced by DM

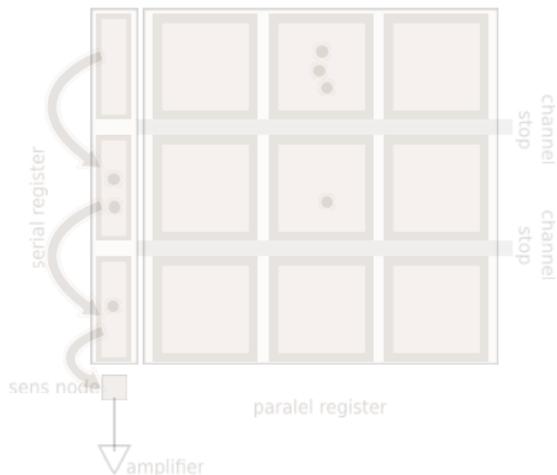


3x3 pixels CCD

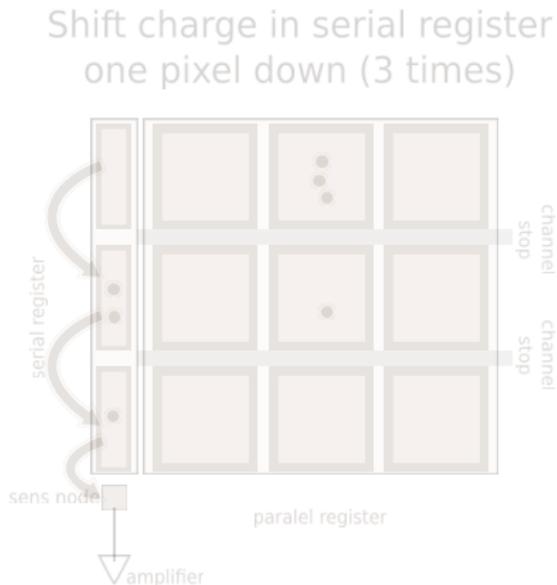
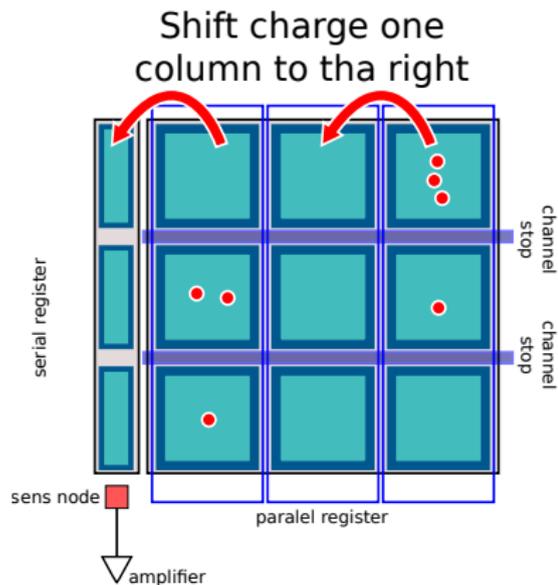
Expose the CCD to particles and collect charge



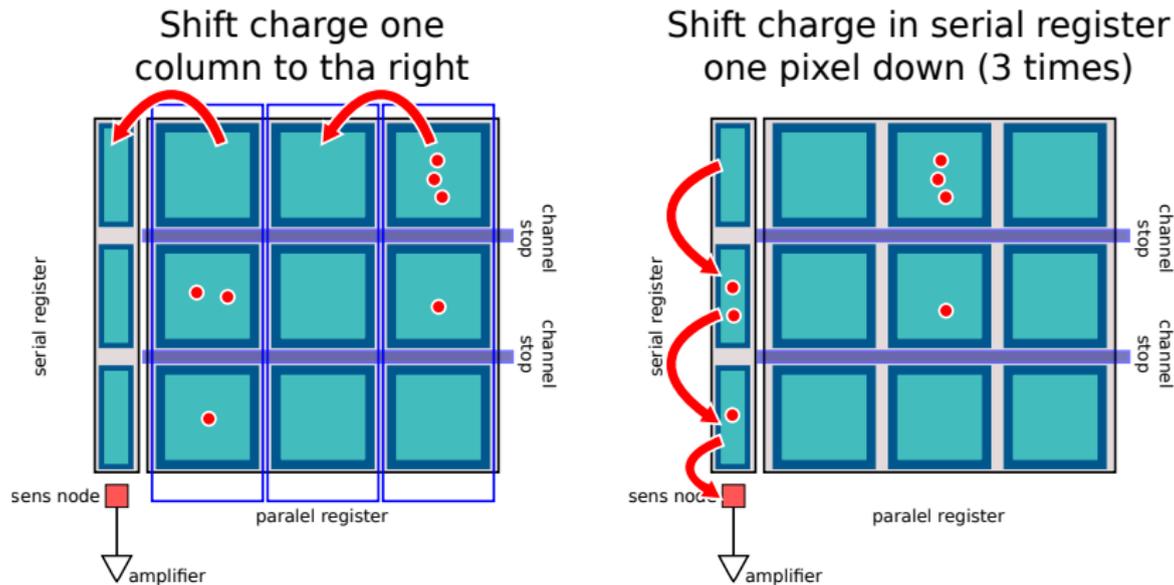
Shift charge in serial register one pixel down (3 times)



3x3 pixels CCD

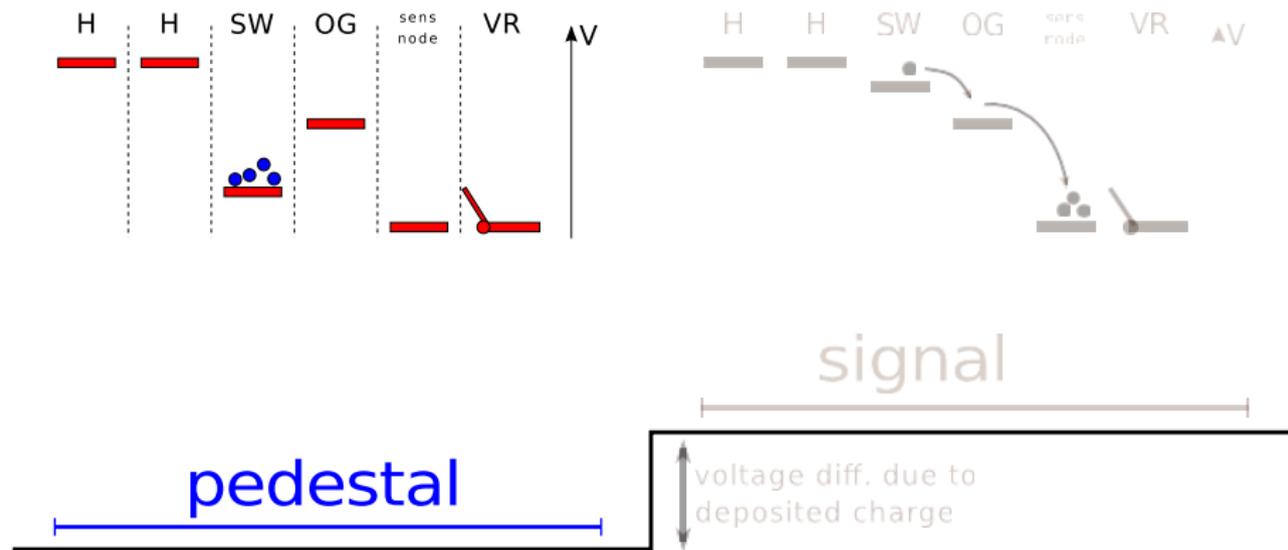


3x3 pixels CCD

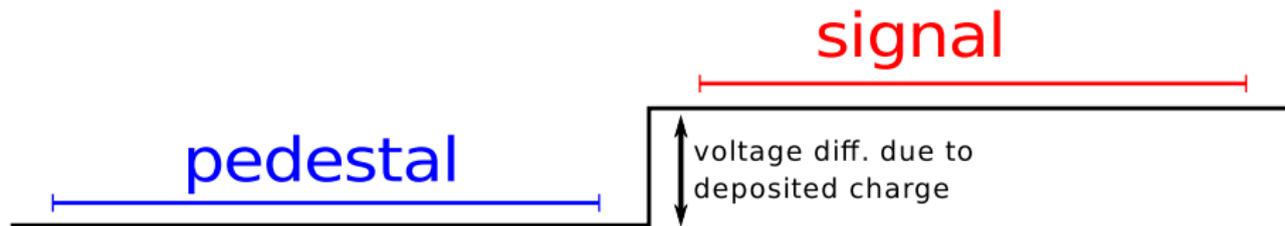
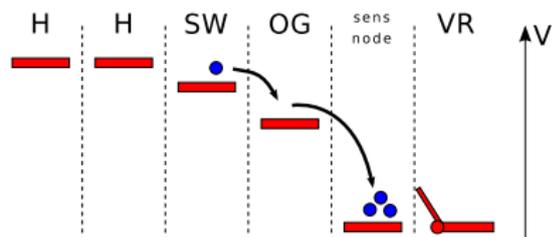
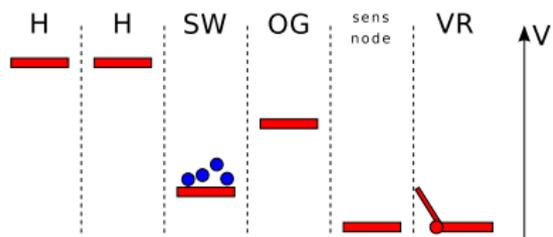


capacitance of the system is set by the SN: $C=0.05\text{pF} \rightarrow 3\mu\text{V}/e$

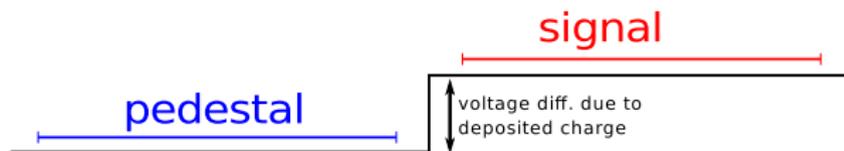
CCD: readout



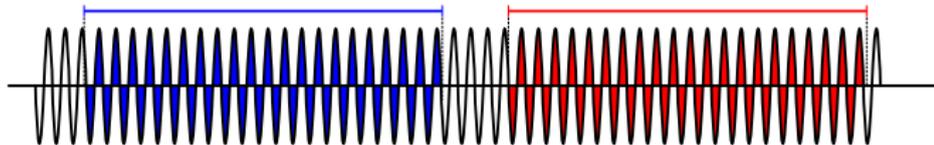
CCD: readout



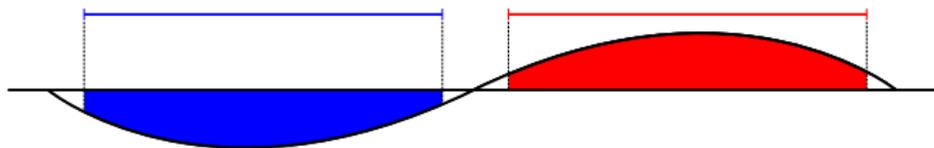
pixel charge
measurement



high frequency
noise

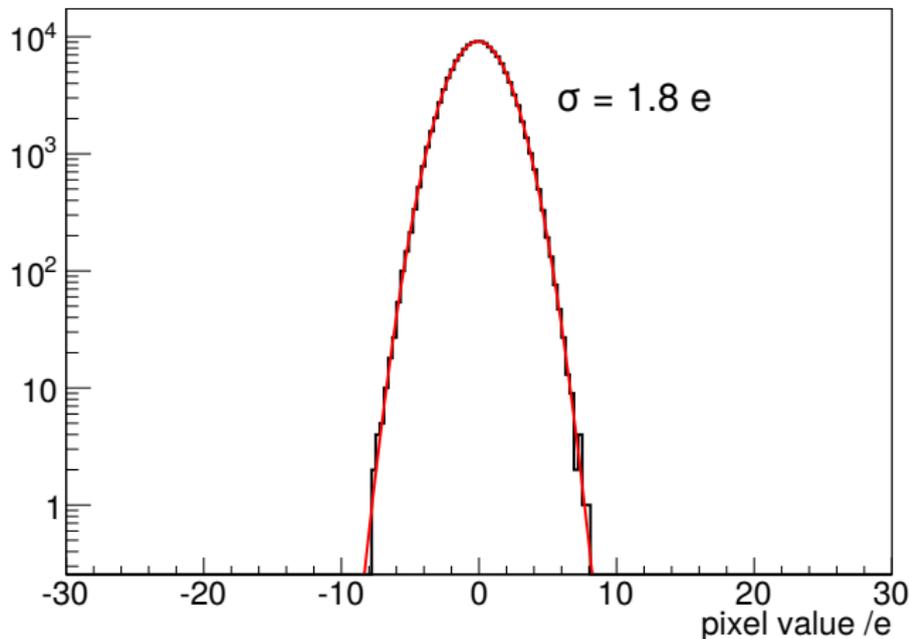


low frequency
noise



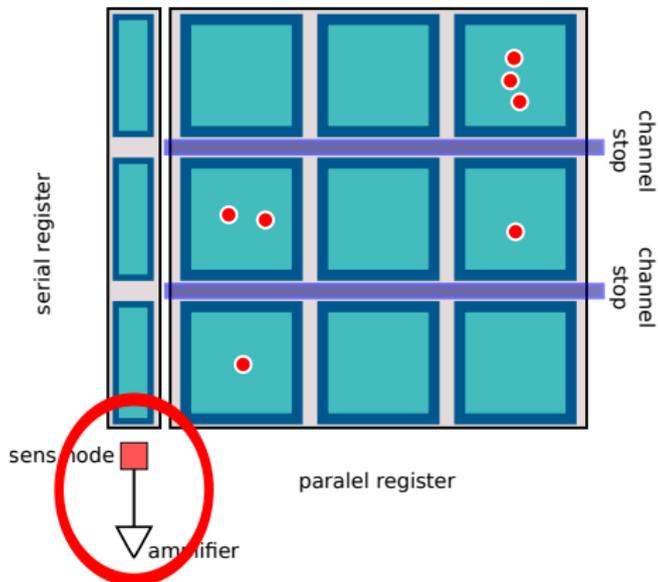
excellent for removing high frequency noise but sensitive to low frequencies

Readout noise: empty pixels distribution



2 e⁻ readout noise roughly corresponds to 50 eV energy threshold

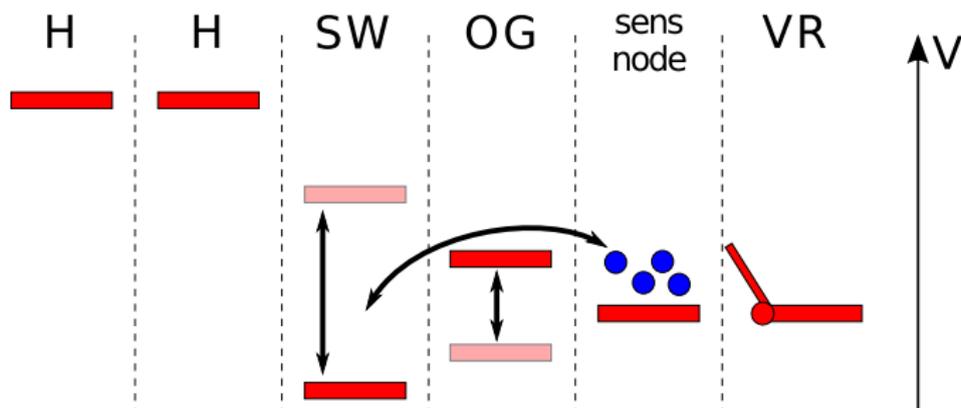
Lowering the noise: Skipper CCD



Only the readout stage is modified

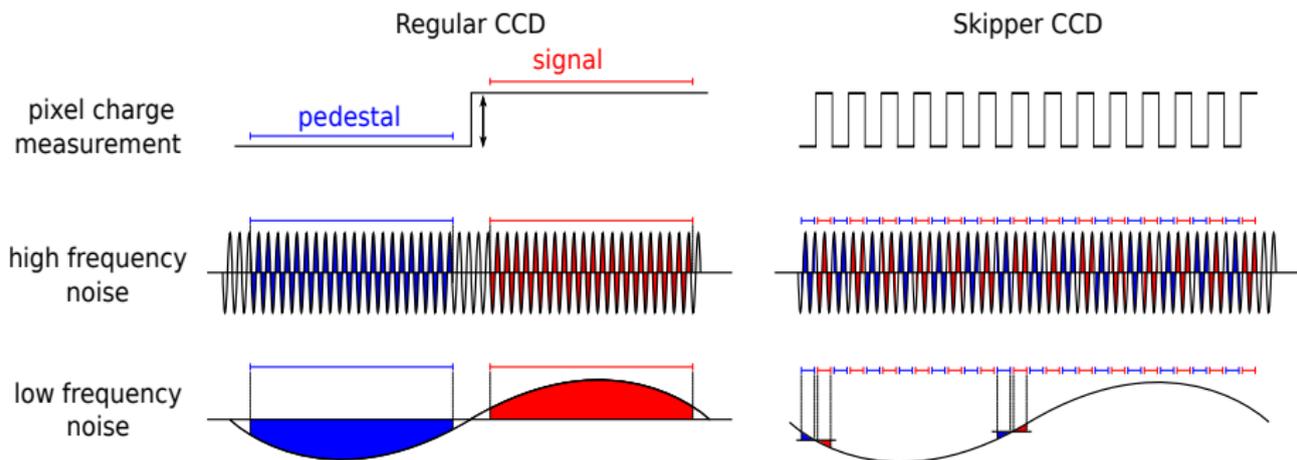
Lowering the noise: Skipper CCD

- **Main difference:** the Skipper CCD allows multiple sampling of the same pixel without corrupting the charge packet.
- The final pixel value is the average of the samples
Pixel value = $\frac{1}{N} \sum_i^N (\text{pixel sample})_i$
- Idea proposed in 1990 by Janesick et al. (doi:10.1117/12.19452)



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Fermilab LDRD-2016-004

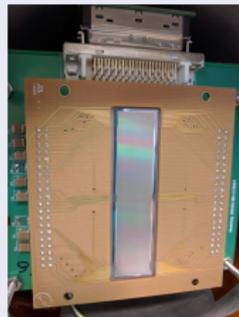
Develop a CCD-based detector with an energy threshold close to the silicon band gap (1.1 eV) and a readout noise of 0.1 electrons using a new generation skipper CCD developed by the **LBNL MicroSystems Lab**

Plan

- Build the first working detector using Skipper-CCDs.
- Optimize the operation parameters and running conditions.
- Produce a low radiation package for the Skipper-CCDs.
- Install the detector in a low radiation environment (MINOS).
- Validate the technology for DM and ν experiments.

SENSEI: First working instrument using SkipperCCD tech

Sensors



- Skipper-CCD prototype designed by **LBL MSL**
- 200 & 250 μm thick, 15 μm pixel size
- Two form factors 4k \times 1k (0.5gr) & 1.2k \times 0.7k pixels
- Parasitic run, optic coating and Si resistivity $\sim 10\text{k}\Omega$
- 4 amplifiers per CCD, three different RO stage designs

Instrument



- System integration done at Fermilab
- Custom cold electronics
- Modified DES electronics for read out
- Firmware and image processing software
- Optimization of operation parameters

Image taken with SENSEI: 4000 samples per pixel (processed)

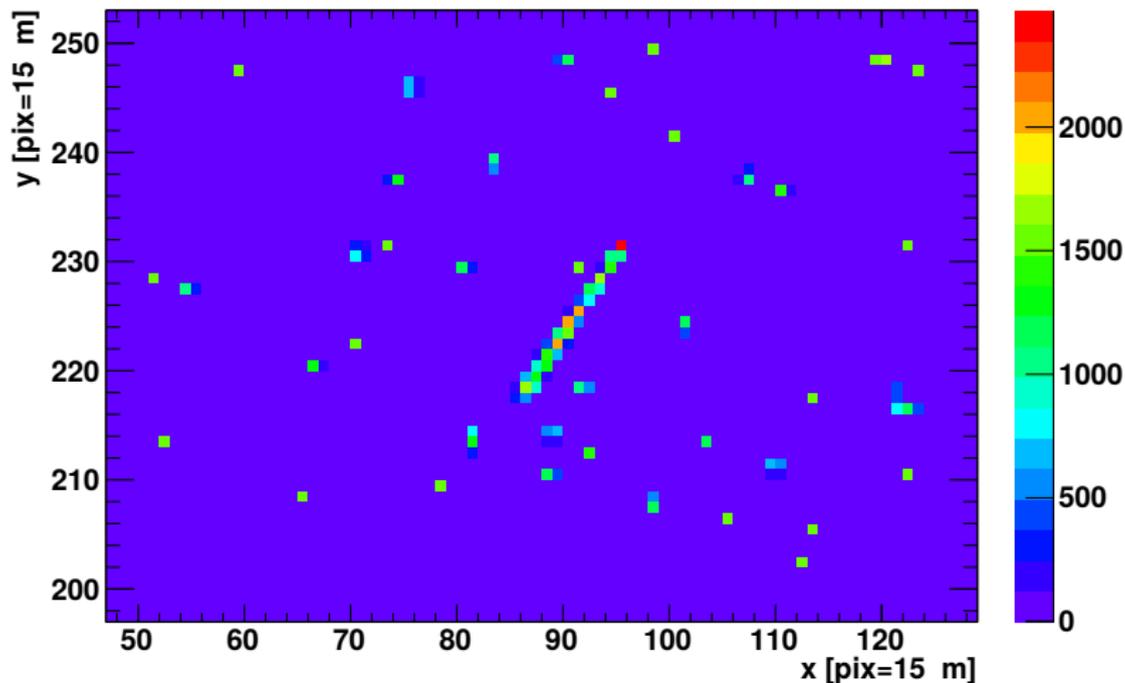


Image taken with SENSEI: 4000 samples per pixel (processed)

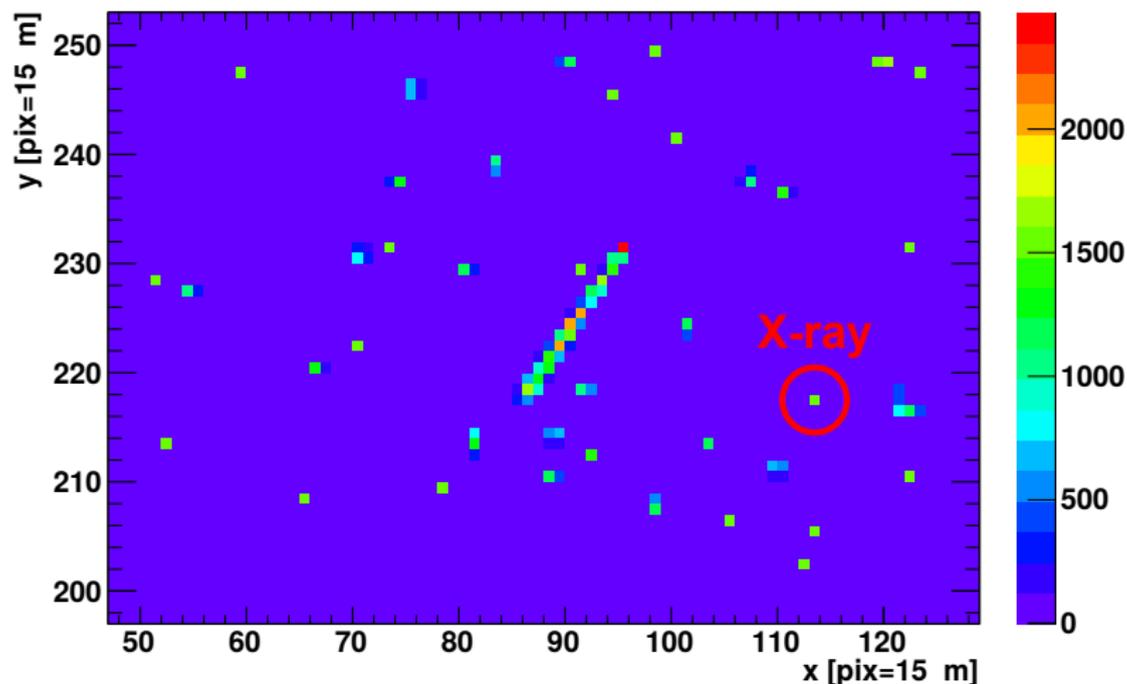


Image taken with SENSEI: 4000 samples per pixel (processed)

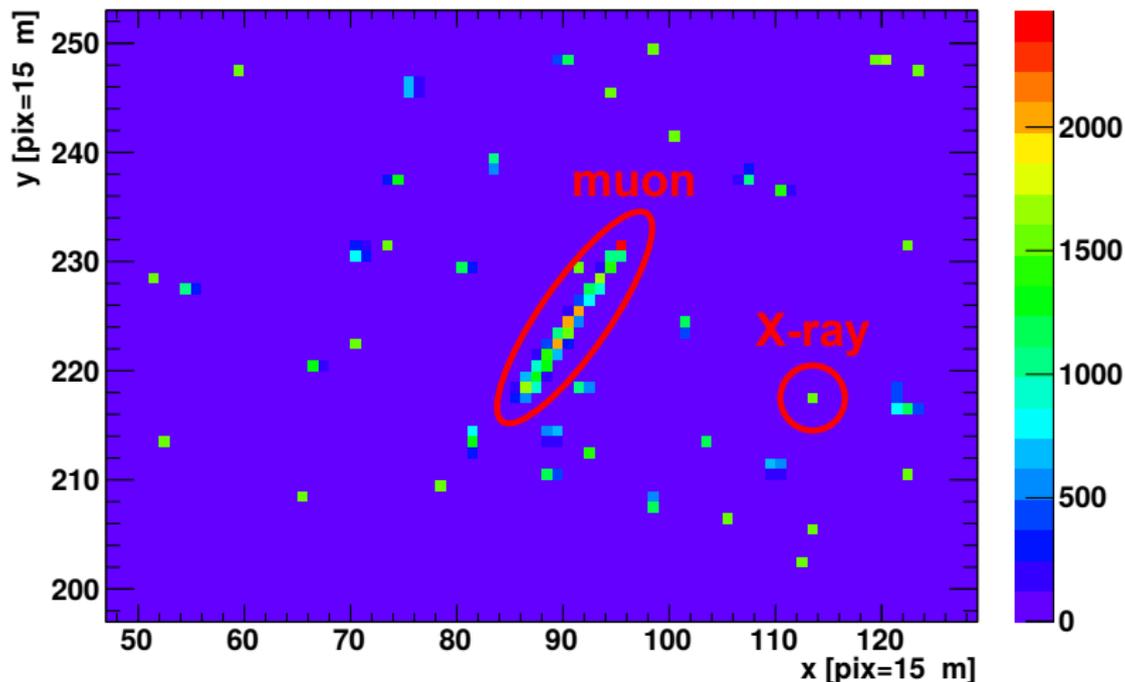
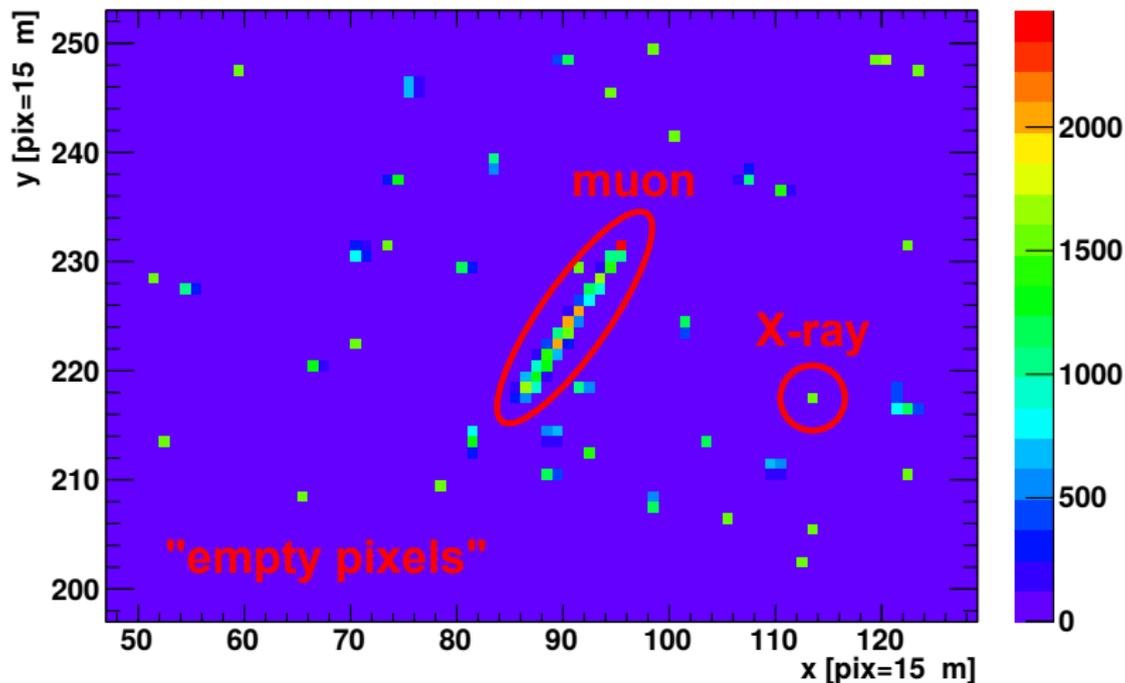
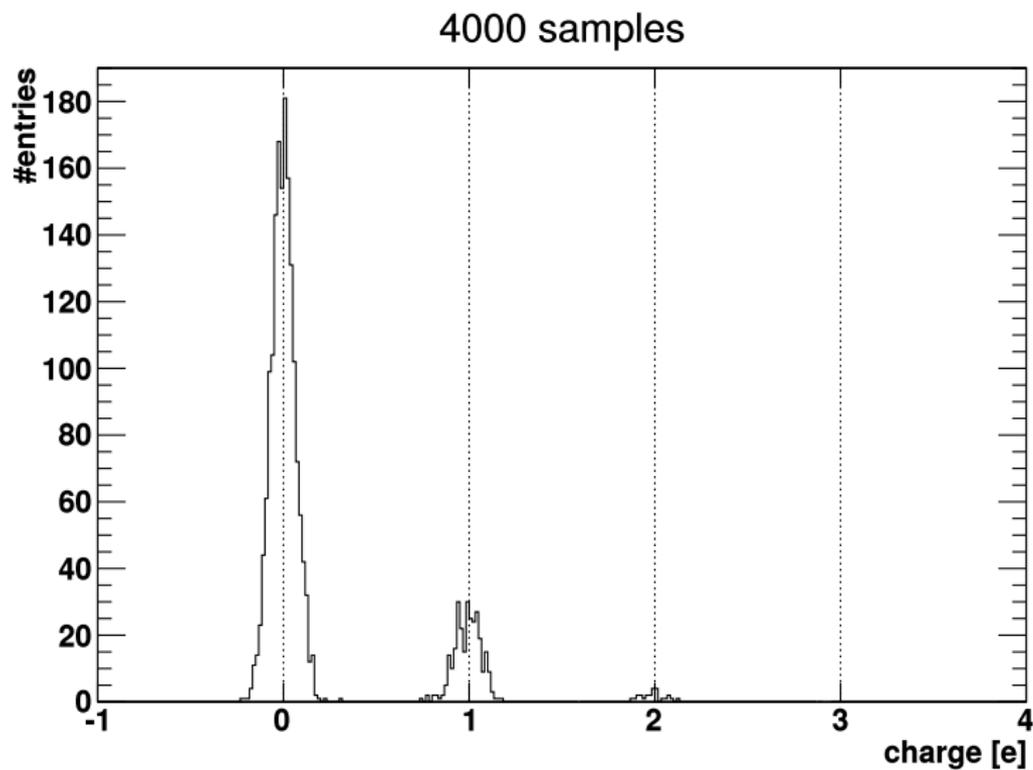


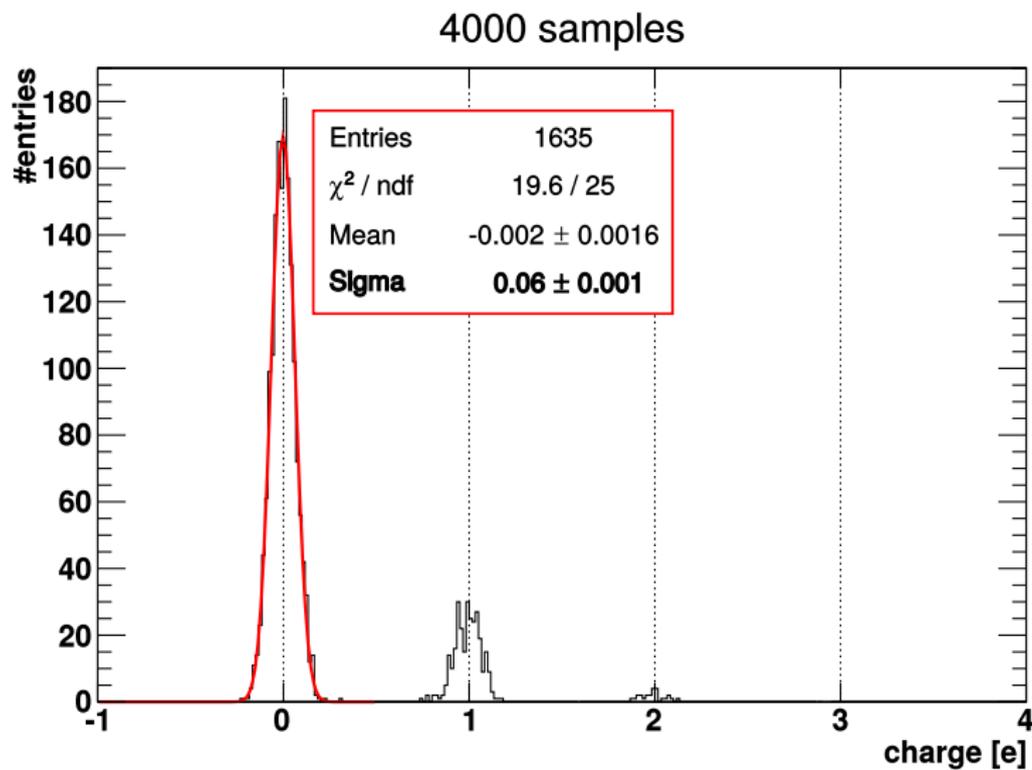
Image taken with SENSEI: 4000 samples per pixel (processed)



Charge in pixel distribution. Counting electrons: 0, 1, 2..

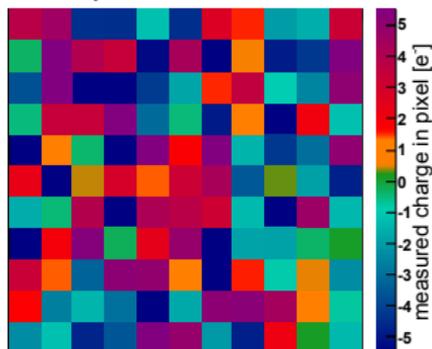


Charge in pixel distribution. Counting electrons: 0, 1, 2..

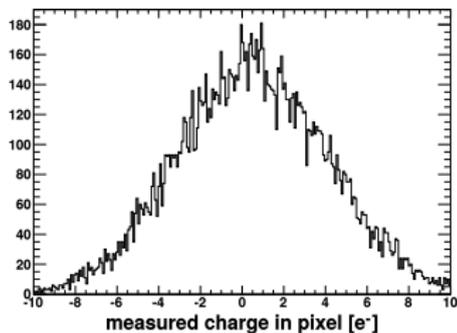


Counting electrons: 0, 1, 2..

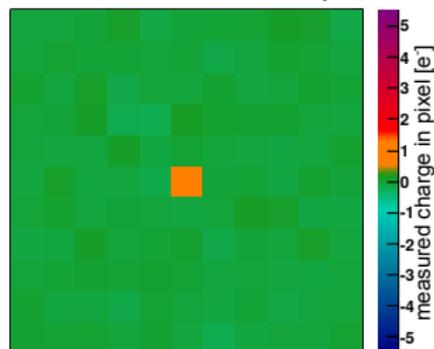
Standard CCD mode: charge in each pixel is measured once



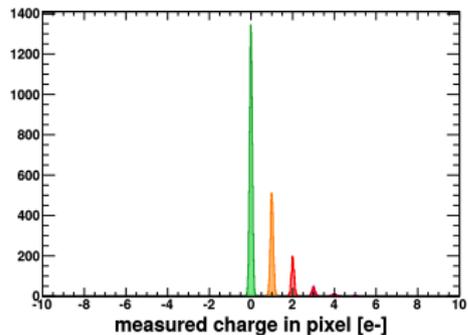
Readout-noise: 3.5 e RMS



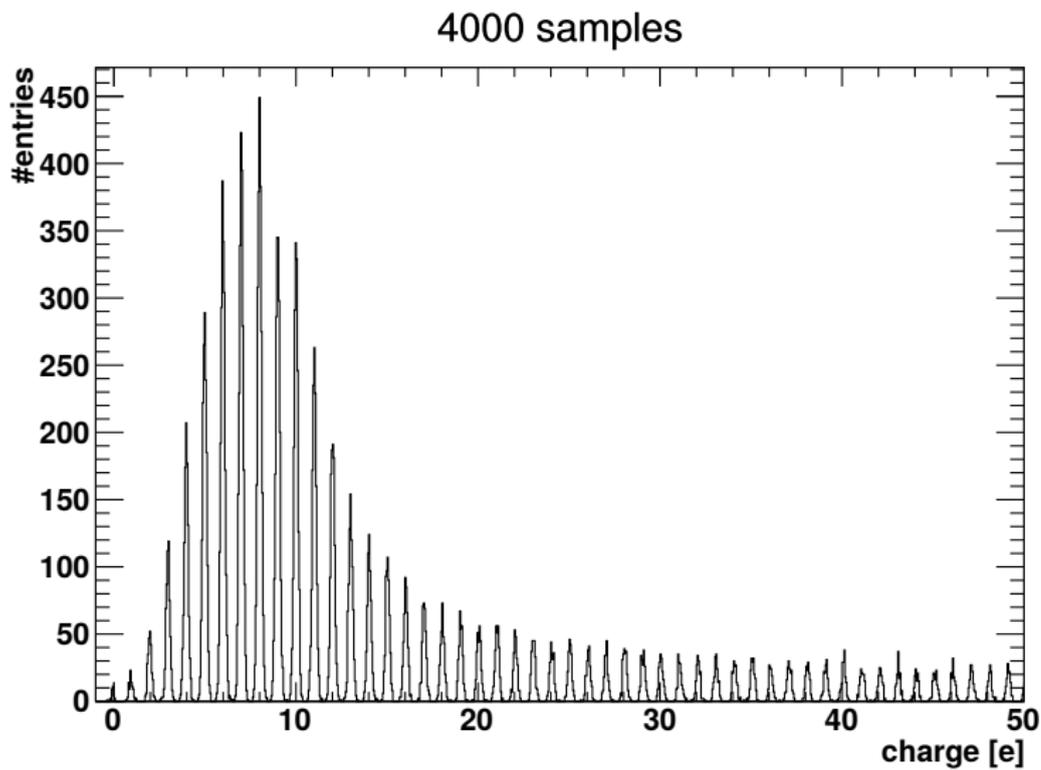
New Skipper CCD: charge in each pixel is measured multiple times



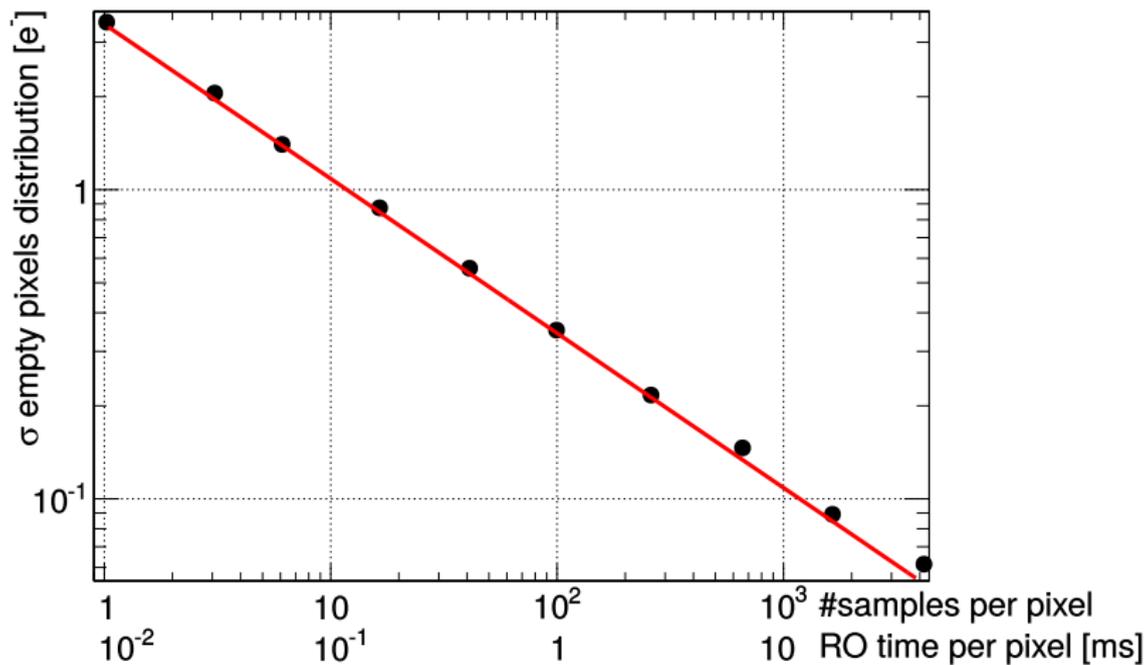
Readout-noise: 0.06 e RMS



Counting electrons: ..48, 49, 50..



Noise vs. #samples - $1/\sqrt{N}$



SENSEI: DM search operation mode

- Counting electrons \Rightarrow **noise has zero impact**
- It can take about 1h to read the sensors
- **Dark Current is the limiting factor**

It's better to readout continuously to minimize the impact of the DC

Dark Current [$e^- \text{pix}^{-1} \text{day}^{-1}$]	$\geq 1e^-$ [pix]	$\geq 2e^-$ [pix]	$\geq 3e^-$ [pix]
10^{-3}	1×10^8	3×10^3	7×10^{-2}
10^{-5}	1×10^6	3×10^{-1}	7×10^{-8}
10^{-7}	1×10^4	3×10^{-5}	7×10^{-14}

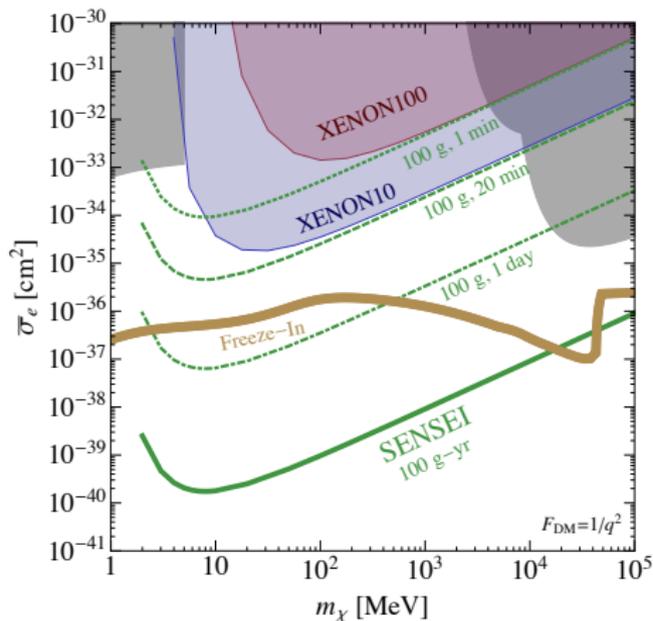
Measured upper limit for the DC in CCDs is:

$$1 \times 10^{-3} \text{ e pix}^{-1} \text{ day}^{-1} \quad \text{arXiv:1611.03066}$$

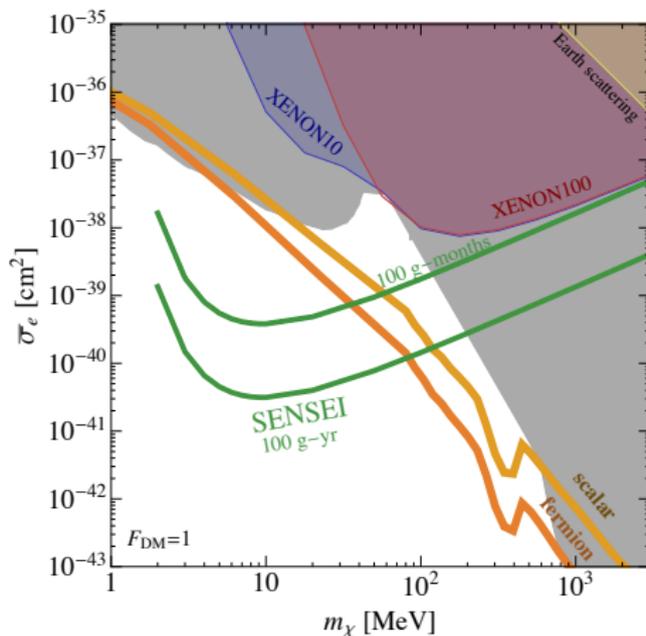
Could be orders of magnitude lower. **Theoretical prediction is $O(10^{-7})$**

SENSEI: reach of a 100g, zeroish-background experiment

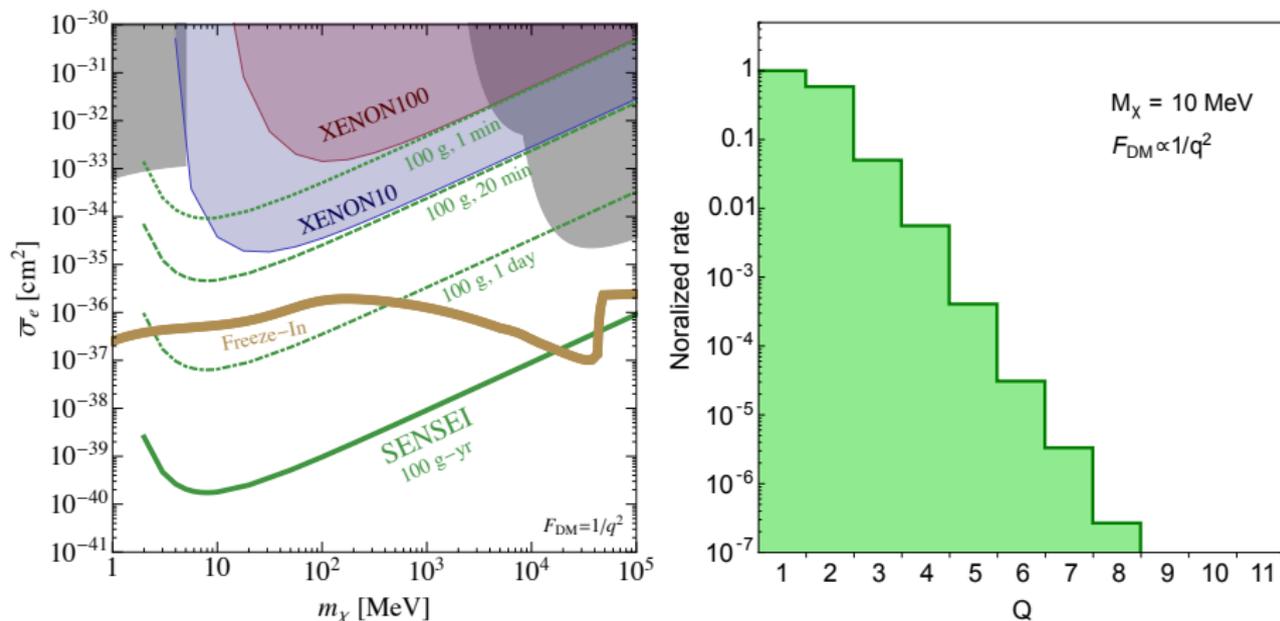
Light Dark Photon



Heavy Dark Photon



The sensitivity is dominated by the lowest energy/charge bin



Rouven Essig, Tomer Volansky & Tien-Tien Yu.

Back of the envelope calculation

A 100g detector that takes data for one year \rightarrow **Expo = 36.5kg · day**

Assuming same background as in DAMIC:

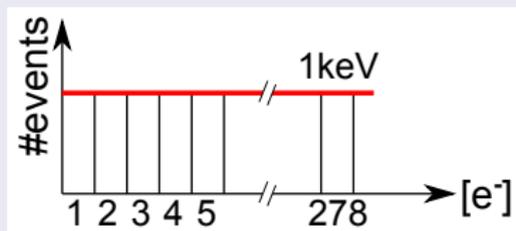
- **5 DRU** ($\text{events} \cdot \text{kg}^{-1} \cdot \text{day}^{-1} \cdot \text{keV}^{-1}$) in the 0-1keV range
 \rightarrow **$N_{\text{bkg}} = 36.5 \text{ kg} \cdot \text{day} \times 5 \text{ DRU} = 182.5$ events**
- Dominated by external gammas \rightarrow **flat Compton spectrum**

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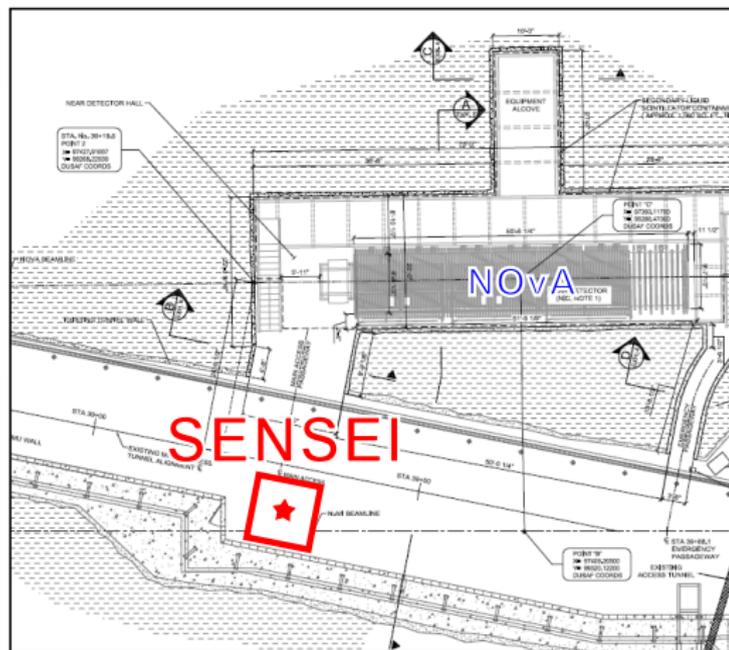
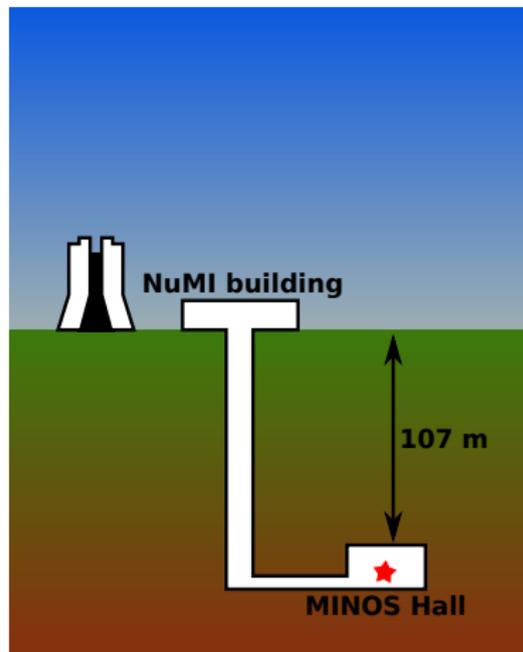


182.5 events over the 278 charge bins in the 0-1keV range

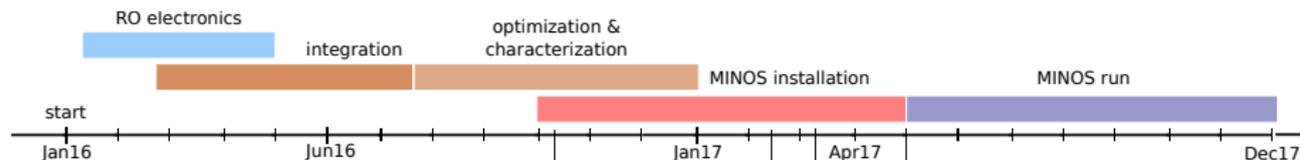
Expect 0.65 bkd events in the lowest (2 e⁻) charge-bin

Whats going on now: Installation @MINOS

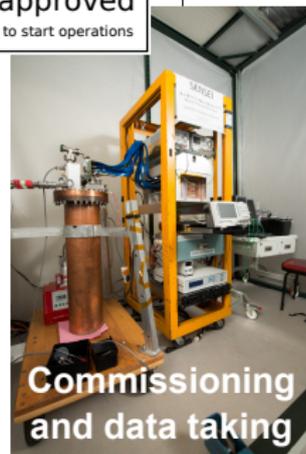
Technology demonstration: installation at shallow underground site



Whats going on now: Installation @MINOS



TSW approved
permission to start operations

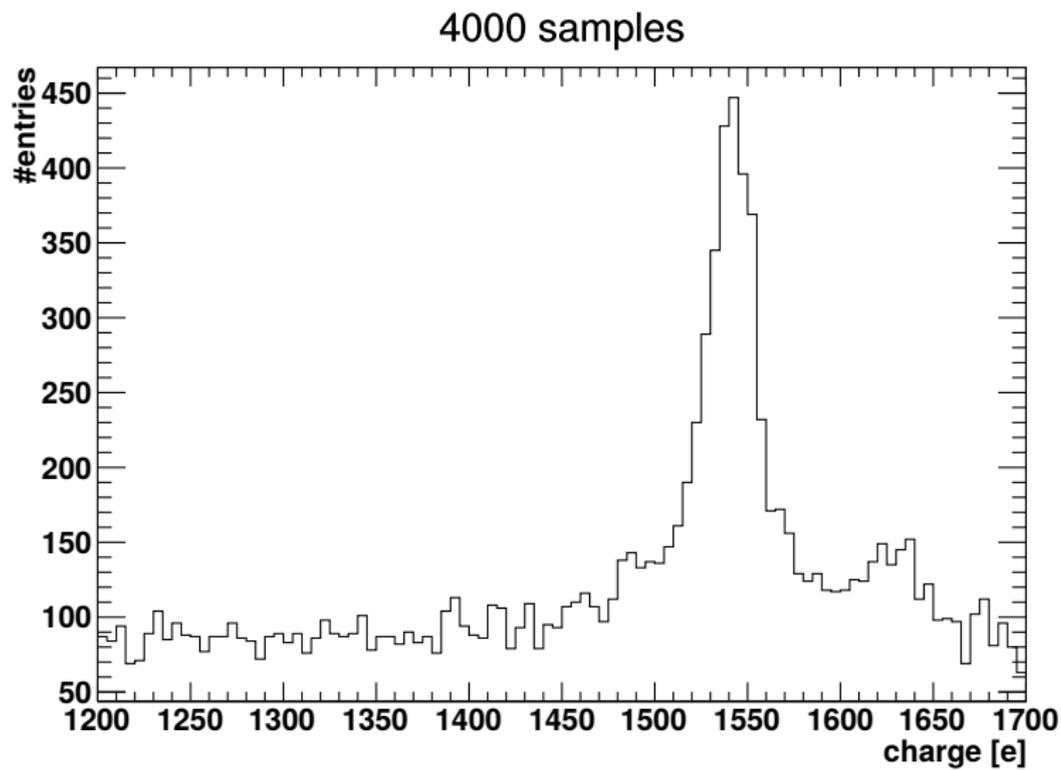


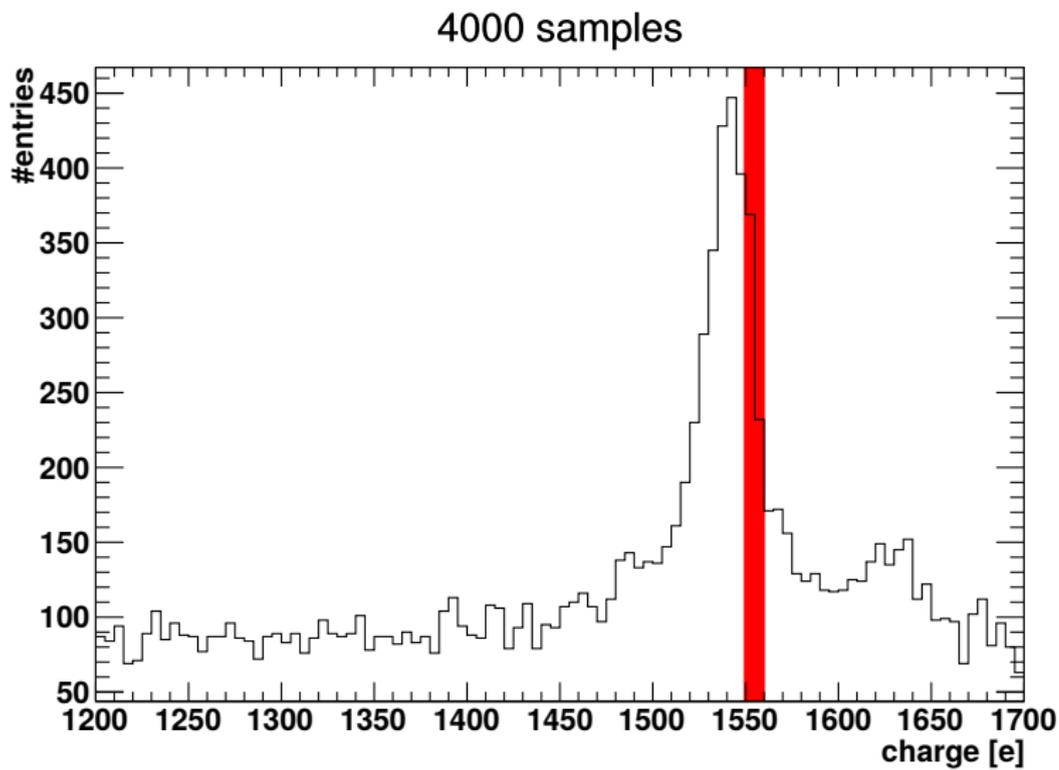
Taking data to understand if current (parasitically-fabricated) detectors are good enough to produce a science result

Summary

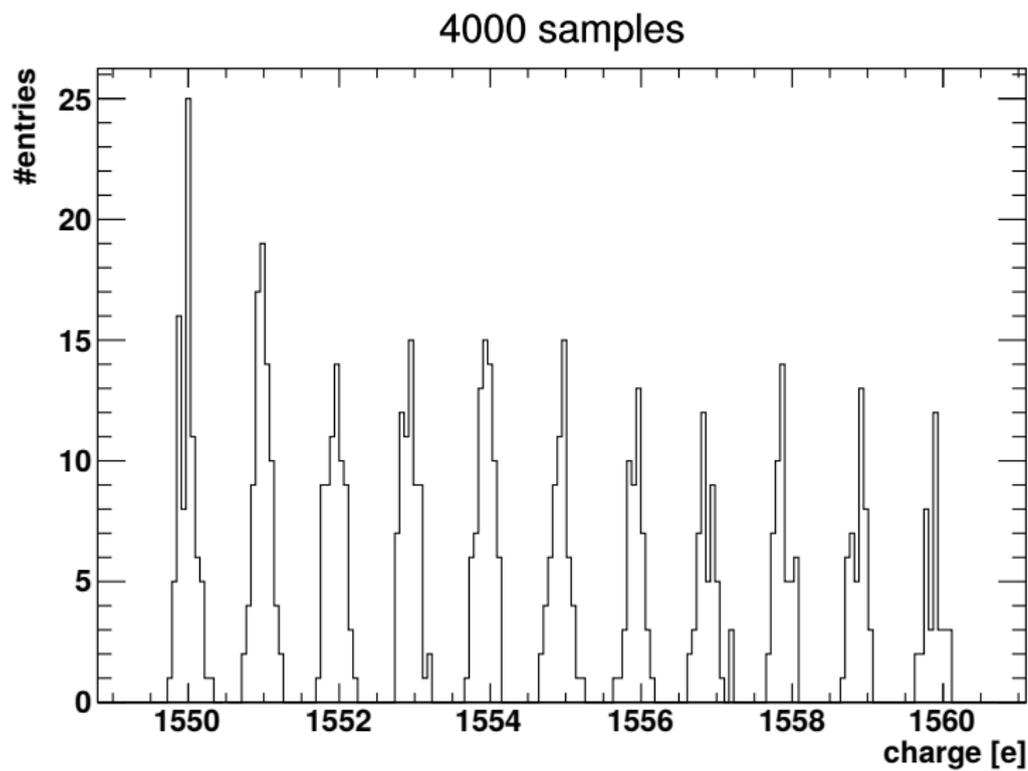
- Demonstrated technology: working detector.
- Demonstrated bkg: no R&D needed.
 - ▶ required bkg level already reached by running experiments.
- Minimal R&D required for the packaging of the sensors.
- 100 g construction could start on FY18.
 - ▶ 1.2 M\$ in 2 yrs (scaled from DAMIC experience).
- Complementary to LDMX and DAMIC-1K.
- Small scale demonstration already running at MINOS. Results by the end of 2017.
- MINOS site is good up to a 10g experiment. Deeper location (Snolab/SURF) is required for 100g.

BACK UP SLIDES

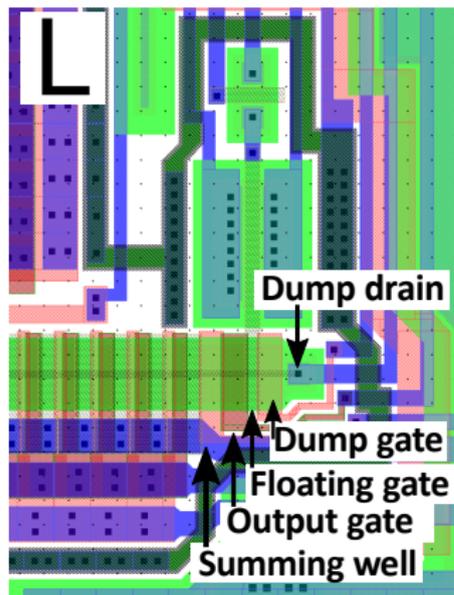




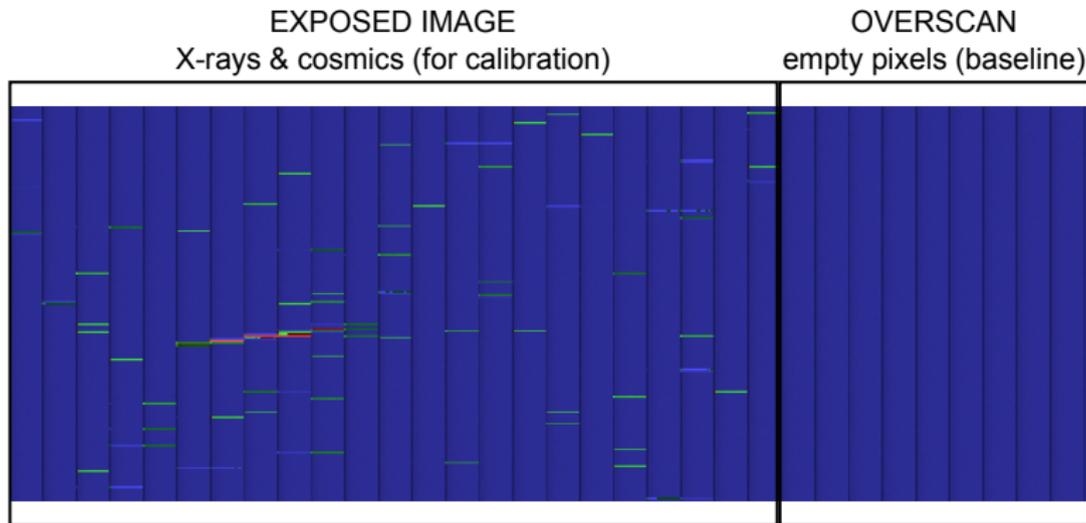
keep counting: ..1550, 1551, 1552..



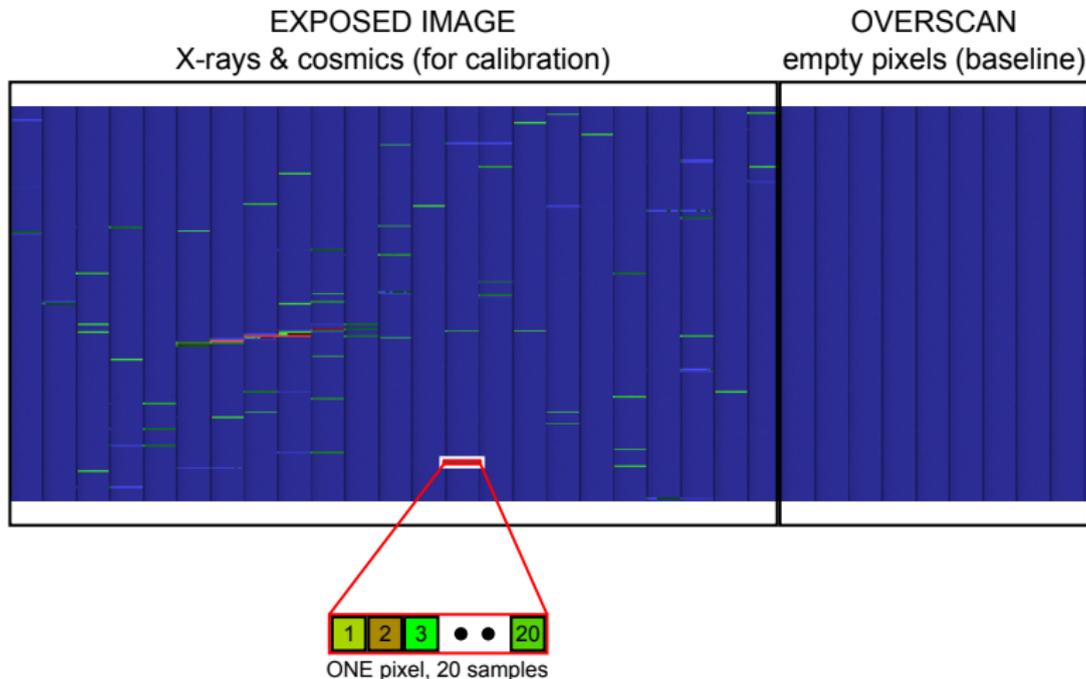
Readout stage design



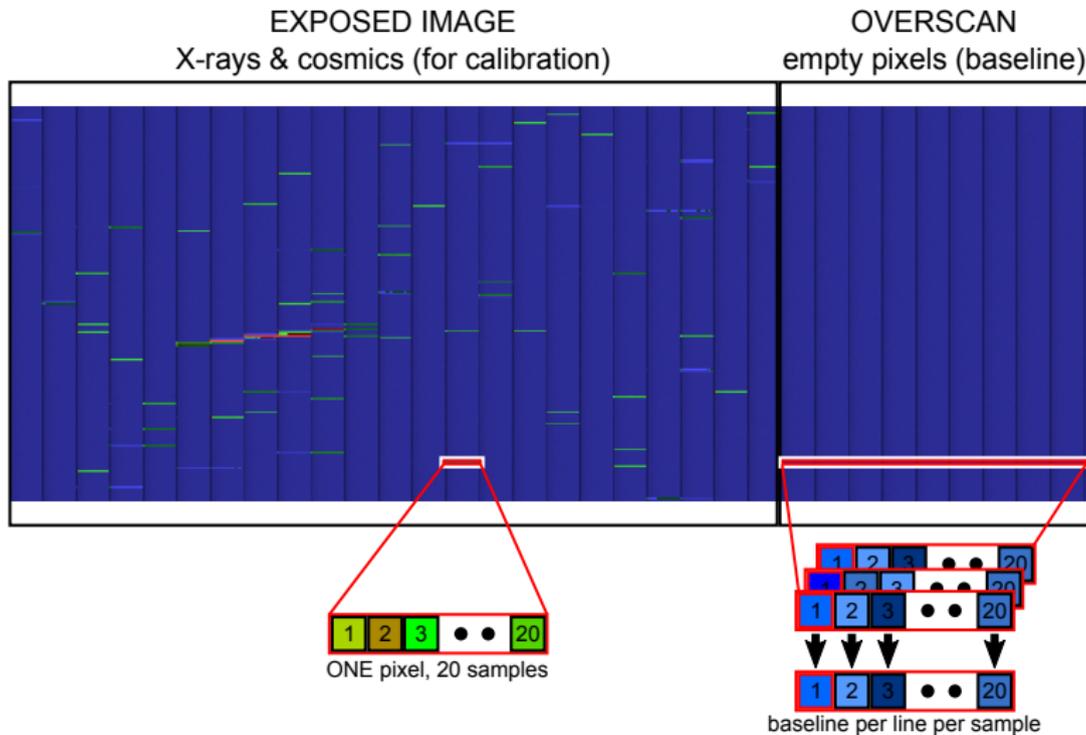
Raw image taken with SENSEI: 20 samples per pixel



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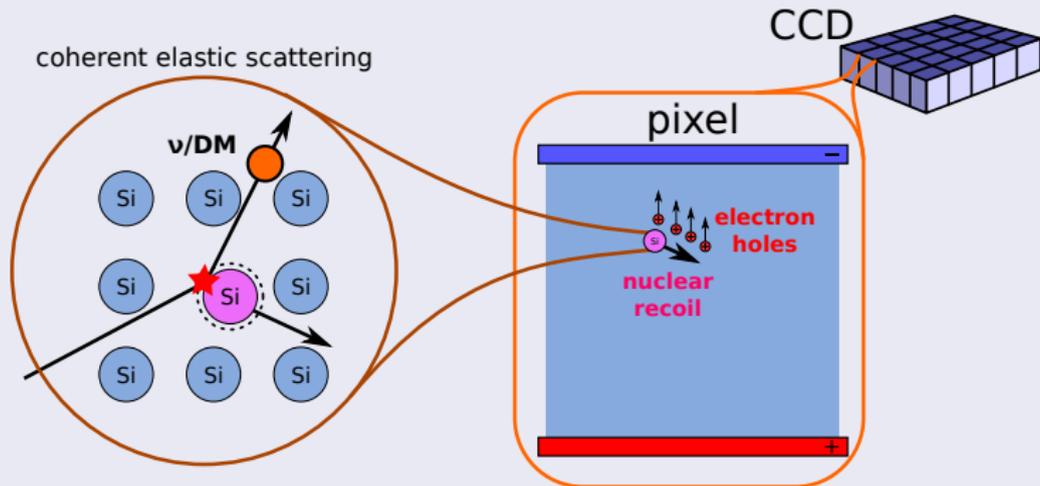
Raw image taken with SENSEI: 20 samples per pixel



Goal: lower the energy threshold in Si detectors

Detect coherent DM/ ν -nucleus interactions by measuring the ionization produced by the nuclear recoils

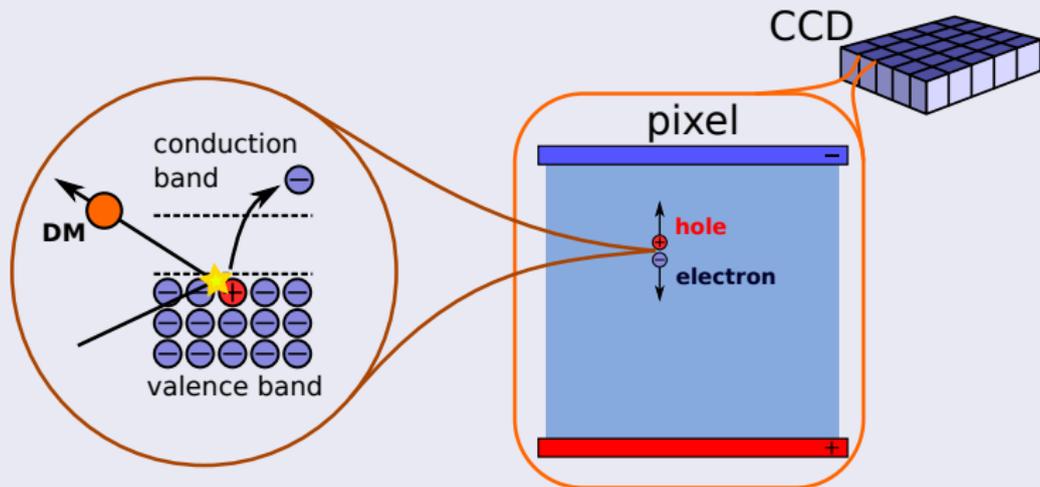
Idea: use CCDs as target and record the ionization produced



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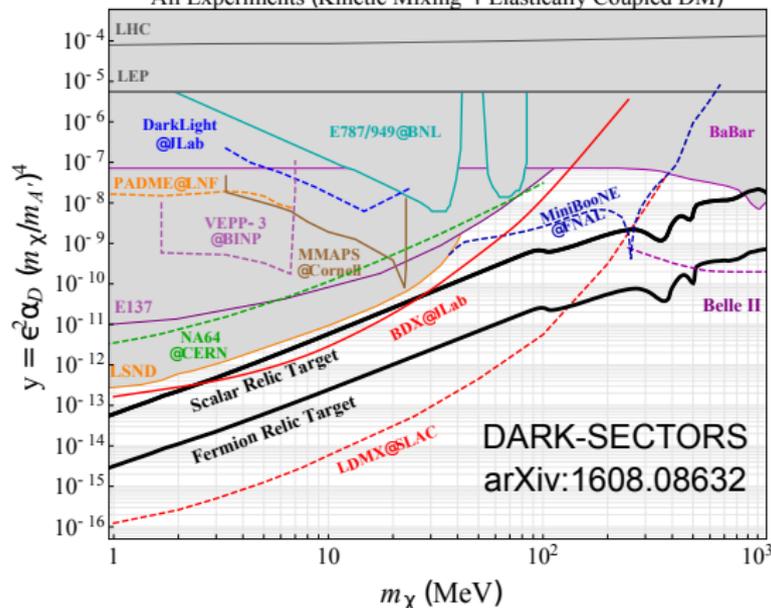
Detect DM/ γ / ν -e interactions by measuring the ionization produced by the electron recoils. See arXiv:1509.01598

Idea: use CCDs as target and record the ionization produced



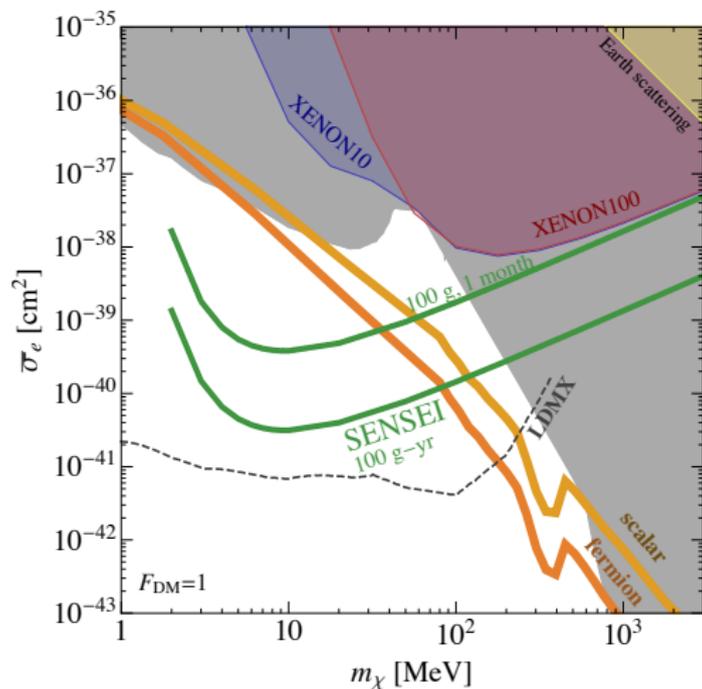
Heavy Dark Photon

All Experiments (Kinetic Mixing + Elastically Coupled DM)



$$\bar{\sigma}_e \simeq \begin{cases} \frac{16\pi\mu_{\chi e}^2\alpha\alpha_D\epsilon^2}{m_{A'}^4}, & m_{A'} \gg \alpha m_e \\ \frac{16\pi\mu_{\chi e}^2\alpha\alpha_D\epsilon^2}{(\alpha m_e)^4}, & m_{A'} \ll \alpha m_e \end{cases}, \text{ and } F_{DM}(q) \simeq \begin{cases} 1, & m_{A'} \gg \alpha m_e \\ \frac{\alpha^2 m_e^2}{q^2}, & m_{A'} \ll \alpha m_e \end{cases}$$

Heavy Dark Photon



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